

<b>Notice of References Cited</b>	Application/Control No. 09/653,156	Applicant(s)/Patent Under Reexamination AGARWAL ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification	
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	B	US-6174770B1	01-2001	Chi	438	255
	C	US-				
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